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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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P. Walker
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Applicants: James M. Holden, William A. McGahan, Richard A. Yarussi,
Pablo I. Rovira, and Roger R. Lowe-Web
Assignee: Nanometrics Incorporated
Title: Apparatus And Method For The Measurement Of Diffracting Structures
Serial No.: 09/670,000 Filing Date: September 25, 2000
Examiner: Unknown Group Art Unit: Unknown
Docket No.: M-9455 US

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COMMISSIONER FOR PATENTS
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying PTO Form-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on October 8, 2001.

Michael J. Halbert 10-8-01
Attorney for Applicants Date of Signature

Respectfully submitted,

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